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Practitioner's Docket No.: SON-1908/DIV
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In the application of: Takeshi NOGAMI

Serial No.: 10/759,194

Filing Date: January 20, 2004

For: METHOD FOR PRODUCING
SEMICONDUCTOR DEVICE, POLISHING
APPARATUS, AND POLISHING METHOD

Group Art Unit: 2812

Confirmation No.: 7751

Attention: Office of Initial Patent Examination's
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Commissioner for Patents
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Alexandria, VA 22313-1450

REQUEST FOR CORRECTED FILING RECEIPT

1. Attached is a copy of the official filing receipt received from the PTO in the above application for which issuance of a corrected filing receipt is respectfully requested.
2. There is an error with respect to the following, which is incorrectly entered.

Error in**Correct data**

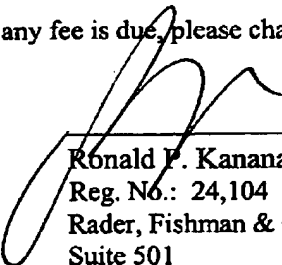
1. Domestic Priority Data

1. DIV of 09/655,833 09/06/2000 Pat. 6,693,036

3. The correction is due to an error by the USPTO. If any fee is due, please charge Deposit Account No. 18-0013.

Dated:

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APPL NO.	FILING OR 371 (c) DATE	ART UNIT	FIL FEE REC'D	ATTY. DOCKET NO	DRAWINGS	TOT CLMS	IND CLMS
10/759,194	01/20/2004	2812	1036	SON-1908/DIV	25	30	4

CONFIRMATION NO. 7751

23353
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1233 20TH STREET N.W., SUITE 501
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FILING RECEIPT



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Date Mailed: 09/15/2004

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Domestic Priority data as claimed by applicant

This application is a CON of 09/655,833 09/06/2000 PAT 6,693,036

Foreign Applications

JAPAN P11-253605 09/07/1999

If Required, Foreign Filing License Granted: 04/21/2004

The number of your priority application, to be used for filing abroad under the Paris Convention is,
US10/759,194

Projected Publication Date: 12/23/2004

Non-Publication Request: No

Early Publication Request: No

Title

Method for producing semiconductor device, polishing apparatus, and polishing method

Preliminary Class

438

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